



EV372471501

Application Serial No. 09/677,478  
Supplemental IDS

MI22-1544

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 09/677,478  
Filing Date ..... October 2, 2000  
Inventor ..... Guy t. Blalock  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1765  
Examiner ..... Lan Vinh  
Attorney's Docket No. .... MI22-1544  
Title: Plasma Etching Methods

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

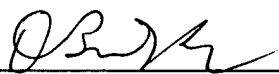
**Reference -- See Attached Form PTO-1449**

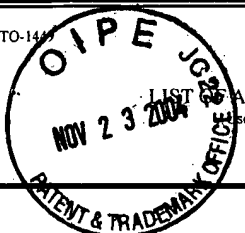
This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to ensure consideration of the reference listed on the attached form PTO-1449.

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted reference is prior art.

Respectfully submitted,

Dated: 11-23-04

By:   
D. Brent Kenady  
Reg. No. 40,045

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1544		SERIAL NO. 09/677,478	
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Blalock et al.		GROUP 1765	
					FILING DATE October 2, 2000			
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,465,051 B1	10/02	Sahin et al.				
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER				DATE CONSIDERED				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								